For Semiconductor Deposition & Etch Applications

Technical Data Sheet (Jul 2019)

### **High Temperature Perfluoroelastomer for Plasma Applications**

PERFREZ® XHT is the newest line of product portfolio products specially developed to handle extreme high temperature combined with aggressive oxygen and fluorine based plasma, while generating minimum particles. The essential aspects of combining high temperature is its ability to maintain the chemical compatibility along with those assets and minimize extrusion and stickiness and be as resilient a seal as possible throughout its operation.



### **Features and Benefits**

- Superior physical properties with better Nitrile CTE values
- ➤ High temperature capabilities up to 300°C
- Excellent oxygen and fluorine compatibility
- Low metal content and manufactured with the best surface finishes and clean rooms per F51-0200 specifications.
- Should also be considered for sub-fab materials as the market faces new chemicals and higher temperatures in all heated lines

# Typical Physical Properties<sup>1</sup>

Color <sup>2</sup>	Grey
Hardness, (Shore A)	76(+/-5)
Elongation at break <sup>3</sup> , %	191
Tensile Strength, psi(MPa)	1771 (12.21)
Modulus @100%, psi(MPa)	939 (6.47)
Coefficient of Thermal Expansion	3.09x10 <sup>-4</sup>
Min. Operating Temperature, °C(°F)	-20(-4)
Max. Operating Temperature, °C(°F)	310(572)

## Compatible Semiconductor Process

- ✓ Deposition: PECVD, APCVD, HDPCVD, RPCVD, SACVD
- ✓ Plasma Etch: Oxide and Metal
- ✓ Ashing & Stripping (where) temperatures are exceeded)
- ✓ Ion Implant
- ✓ RTP
- ✓ Diffusion

Not to be used for specification purposes

<sup>2</sup>Color variations may be observed in actual product. They are considered to be cosmetic and inherent as a result of curing process, not indicative for foreign matter and is not expected to have an adverse effect on the performance of the part in service.

<sup>3</sup>Even though elongation property is indicated, most perfluoroelastomer materials should not be stretched for optimal performance <sup>4</sup>ASTM D395-O3, Method B

### **Applications:**

- ✓ Chamber Lid Seals
- ✓ End Point Windows
- ✓ Isolator Valve Seals
- ✓ Slit Valves

- ✓ Door Seals
- ✓ Gas Inlet Seals
- ✓ KF-Fittings
- ✓ Window Seals

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